



NOZZLE PLATE AND METHOD FOR SURFACE TREATMENT OF SAME

The invention relates to a nozzle plate adapted for an ink-jet type recording apparatus and the surface treatment of the nozzle plate.

In an ink-jet type recording apparatus which records an image on a recording medium by ejecting ink droplets from a nozzle, there exists a problem in that, when a portion surrounding a nozzle is wetted by an ink, deviation in the direction of the flight of ink droplets occurs.

To address this type of problem, Unexamined Japanese Patent Publications (Kokai) Nos. Sho. 55-65564 and Sho. 57-107848 have proposed an apparatus in which water-repellency treatment is performed on the nozzle plate surface surrounding a nozzle thereby to suppress generation of such wetting by the ink. However it is difficult to restrict the treatment to the nozzle plate surface only. Unexamined Japanese Patent Publication (Kokai) No. Hei. 2-48953 discloses a method whereby a plate impregnated with a silicon water-repellent agent is employed to wipe the surface of a nozzle plate, or pressure is applied to the surface of the nozzle plate by a porous member impregnated with a water-repellent agent.

In this case, with the resulting lining of the inner portion of a nozzle by a portion of the water-repellent agent, when ink drops are ejected at high speed from the nozzle, they contact the water-repellent agent adhered to a portion of the



inner surrounding surface of the nozzle and the problem of a marked disruption of the direction of the flight of the ink droplets occurs as before.

An object of the present invention, in view of the above-mentioned problem, is to provide a new nozzle plate capable of preventing the flight of ink droplets from deviating.

Another object of the invention is to provide a novel nozzle plate surface treatment method of forming a water-repellent coating on the surface of a nozzle plate while restricting the lining of the inside of the nozzle with the water-repellent material.

According to the present invention, there is provided a nozzle plate which incorporates a water-repellent coating formed on the nozzle plate surface surrounding the nozzle hole in such a way as to leave a portion not exceeding 20% of the diameter of the nozzle hole uncoated.

Also, there is provided a method of forming a water repellant coating layer on a nozzle plate surface, the method comprising: laminating a front surface of said nozzle plate with a photosensitive resin material which may be hardened by exposure to a light source, at least one portion of said photosensitive resin material entering the inner portion of said nozzle; exposing a portion of said photosensitive resin material directly above said nozzle from a rear surface of said nozzle plate to a light source sufficient to harden a portion of said photosensitive resin material to a size at least that of said nozzle diameter, being no larger than 1.4 times that of the diameter of said nozzle, thereby hardening said photosensitive resin material; and forming the water-repellent coating layer on the upper surface of said nozzle plate using said hardened portion of said photosensitive resin material as a means to form the shape of said water-repellant coating layer.

Further, there is provided a nozzle plate surface treatment method comprising forming a water-repellant coating layer on the nozzle plate by the aforementioned method and removing the hardened portion of said photosensitive resin material.

Embodiments of the present invention will now be described by way of example, with reference to the accompanying drawings, in which:-

Figures 1 (a) to (f) are diagrams showing a process for surface treatment of a nozzle plate, which is an embodiment of the invention;

Figure 2 shows a cross-section diagram of an example of a nozzle plate formed according to the above-mentioned process;

Figure 3 shows the relationship between the quantity of photosensitive film entering the nozzle of a nozzle plate and the exposure value of ultra-violet radiation;

Figures 4 (a) to (e) are diagrams showing a production process for a nozzle plate, which is another embodiment of the present invention.

Figures 1(a) to 1(e) shows a nozzle plate surface treatment process, which is an embodiment of the invention, and Figure 2 shows an example of a nozzle plate formed using this process.

In Figures 1(a) to 1(f), a nozzle plate 1 is made of a material such as metal, ceramic, silicon, glass or plastic; and preferably of a single metal such as titanium, chromium, iron, cobalt, nickel, copper, zinc, tin, gold; or of an alloy such as a nickel-phosphor alloy, a tin-copper-phosphor alloy (phosphor bronze); a copper-zinc alloy, or a stainless steel; of polycarbonate, polysulfone, an ABS resin (acrylo

nitrile butadiene-styrene copolymer), polyethylen terephthalate, polyacetal; and various photosensitive resins.

The nozzle plate 1 has a plurality of nozzle holes 4, each consisting of an inverted funnel-like portion 4a on a rear surface 3 and a thinly opened orifice portion 4b on a front surface 2.

Firstly, a photosensitive resin film 6, for example Dialon FRA305-38 (product name) dry resist film made by Mitsubishi Layon, is laminated onto the front surface 2 of nozzle plate 1. Next, the photosensitive resin film 6 is heated to a temperature above glass transition temperature (above $72\pm 1^{\circ}\text{C}$) and pressure is applied so that a portion of the film 6 on the rear surface 3 enters the inner portion of the nozzle 4 in the form of a plug 6a of a length of more than $8\mu\text{m}$ (Fig.1 (a)).

Next, the rear surface 3 of the nozzle plate 1 is exposed to ultraviolet radiation, the photosensitive resin plug 6a within the inner portion of the nozzle hole 4 is hardened, with the ultraviolet radiation passing through the inner portion of the nozzle hole 4, arriving at the surface and being diffracted, deflected and irregularly reflected in such a way as to harden the photosensitive resin film 6 to form an extensive portion 6b of a concentrically circular shape and of a size at least that of the nozzle hole diameter d , being no larger than 1.4 times that of nozzle hole diameter d , and having a preferred diameter b of 1.2 times that of d (Fig.1 (b)).

The diameter of the extensive portion 6b being influenced by the quantity of the photosensitive resin film 6 which entered the inner portion of the nozzle 4, together with the

extent of the exposure; experiments were conducted using a standard nozzle plate (that is nozzle plate 1, with a plate thickness T of $80\mu\text{m}$, a nozzle diameter d of $40\mu\text{m}$, and a funnel-shaped nozzle portion 1 with a length l of $35\mu\text{m}$) varying the amount of ultraviolet radiation (with a wavelength of 365 nm) E (exposure energy)- having a wavelength of 365 nm - applied to the nozzle plate rear surface 3 and the quantity of photosensitive resin film 6 which entered the inner portion of the nozzle 4. Fig. 3 shows the results obtained in these experiments.

The results show that, in the case where the amount of exposure E was substantially smaller with respect to the quantity t of resin film 6 which entered the inner portion of the nozzle 4, the diameter D of the extensive portion 6b formed directly above the nozzle 4 was smaller than the nozzle diameter d and furthermore, in the case where the amount of exposure E was substantially larger with respect to the quantity t of resin film 6 which entered the inner portion of the nozzle 4, the diameter D was in excess of 1.4 times diameter d and, as described later, it became impossible to avoid the deflection in the direction of flight of the ink drops. Consequently, the required amount of exposure E with respect to the necessary quantity t of resin film 6 entering the inner portion of the nozzle 4 was determined to be as follows:

In the case where $18 \leq t \leq 30$, the exposure value E is 300 mJ/cm^2 .

In the case where $30 < t \leq 35$, the exposure value E is 600 mJ/cm^2 .

Further, the resin plug 6a, formed according to this process, being a tight fit within the inner portion of nozzle 4, prevents the extensive portion 6b from falling out of nozzle 4 during the coating layer forming process and also prevents the intrusion of the water-repellent macro-molecular resin into the inner portion of nozzle 4. In addition, the projecting extensive portion 6b formed on the nozzle plate front surface 2 works as a shape-forming means while eutectoid plating is carried out.

Next, a photosensitive resin material 7, which hardens under exposure to a light source, is applied in liquid form to both the front and rear surfaces 2 & 3 of nozzle plate 1 and under exposure from the rear surface 3, the photosensitive resin 7 on the rear surface 3 hardens in the form of a membrane (Fig. 1 (c)).

Next, the remaining unexposed photosensitive resin film 6 on the front surface 2 of nozzle plate 1 and the photosensitive resin material 7 is removed with solvent and acid cleaning is carried out (Fig.1 (d)); then the nozzle plate 1 is immersed in an electrolytic solution in which nickel ions and particles of a water-repellent macro-molecular resin such as polytetrafluoroethylene are dispersed by electrical charges, and coating layer 8 is formed on the front surface 2 of nozzle plate 1 whilst the solution is agitated (Fig.1 (e)).

Polytetrafluoroethylene, polyperfluoroalkoxybutadiene, polyvinylidene, polyfluorovinyl and polydiperfluoroalkyl fumarate may be used individually or in combination as the

fluorine-containing macro-molecule for the eutectoid plating process. There is no particular restriction on the matrix for the coating layer 8; a suitable metal such as nickel, copper, silver, zinc, tin may be selected. Preferred materials include nickel, nickel-cobalt alloy, nickel-phosphor alloy and nickel-boron alloy with good surface hardness. Moreover, materials with superior abrasion-resistance properties should be chosen.

In this way, the polyfluoroethylene particles uniformly cover the entire front surface 2, of nozzle plate 1, except for that portion surrounding nozzle 4; where an area without water-repellence 5, of a concentrically circular shape and with a width W of no more than $0.2 d$ (defined by the shape of extensive portion 6b formed on the front surface 2 of nozzle plate 1), is left.

Further, using a suitable solvent, those portions of the photosensitive resin film 6, used as plugs, and those portions of photosensitive resin material 7, used as a protective membrane, are dissolved and removed. Avoiding the generation of warpage in the nozzle plate 1 by applying a load to the nozzle plate, a hard ink-repellent coating layer 8 is formed on the front surface 2 of nozzle plate 1 by heating it to a temperature (350°C or above) higher than that of the melting point of the polytetrafluoroethylene (Fig.1 (f)).

Forming the nozzle plate 1 in this way, as shown in Fig.2, whilst avoiding any intrusion of material within the inner portion of nozzle 4, an ink-repellent coating layer 8 is formed on the front surface 2 only.

Thus, using a nozzle plate 1 constructed in this way recording may be carried out and ink droplets ejected at high speed from nozzle 4 will fly correctly in relation to the recording medium. Therefore, in the case where a non-water-repellent surface 5, with a width not exceeding 20% of the nozzle diameter d , is formed on the portion surrounding the nozzle 4, excess ink is either returned to the ink chamber along the inner walls of nozzle 4 or spreads equally around the entire circumference of the non-water-repellent surface 5 forming an area of uniform wetting, these taken together acting to prevent disruption of the flight of the ink droplets. Furthermore, ink remaining on the ink-repellent coating layer 8 adheres to an area where it does not affect the flight of the ink droplets, held in spherical form by surface tension; thus the ink droplets, unaffected by these influences, fly correctly in the direction of the axis of nozzle 4.

This type of nozzle plate 1- with an ink-repellent coating 8 (including a non-ink-repellent surface 5 with varying diameters) being performed on the front surface 2 of nozzle plate 1- has been installed in a 'drop-on-demand' type ink jet printer employing a piezo transducer drive system, and a test has been conducted, whereby $0.1 \mu\text{g}$ /dot ink droplets were ejected 100 times at 30 second intervals from a nozzle 4 with a diameter of $40 \mu\text{m}$, with the resultant number of occurrences of deviation in the flight of ink droplets being recorded.

W μ m	Occurences
0.0	21
0.5	0
1	0
4	0
8	7
10	68

From the above results, we discovered that, in the case where the ink repellent coating layer 8 was extended right to the edge of nozzle 4, a portion of the coating layer 8 entered the inner surface of nozzle 4 and adversely affected the flight of the ink droplets. Further, in the case where a non-water-repellent surface 5, with a diameter W of more than 20% of that of nozzle 4 diameter d, was formed on the portion surrounding nozzle 4, we found a deviation in the flight of ink droplets equal to that which occurred in the case where water-repellent treatment was not performed on the front surface 2 of nozzle plate 1.

Figure 4 shows the second embodiment of the method of nozzle plate surface treatment which is the subject of this invention.

In this method, firstly a photosensitive resin film 6, which can be hardened by exposure to a light source, is applied to the front surface 2 of nozzle plate 1 furthermore, a photosensitive resin material 7 which can be hardened by exposure to a light source is applied to the rear surface 3 (Fig. 4 (a)).

Next, the entire area of the rear surface 3 of nozzle plate 1 is exposed to ultra-violet radiation, thereby hardening the photosensitive resin material 7 on the rear surface 3 and within the nozzle 4 forming plug 6a. Furthermore, the ultra-violet radiation which passes through the nozzle 4 hardens the portion of the photosensitive resin film 6 directly above the nozzle 4 to an extent of at least the diameter of the nozzle d , and not exceeding 1.4 times the diameter d , thus forming extensive portion 6b (Fig. 4 (b)).

Next, the unexposed portion of photosensitive resin film 6 on the nozzle plate front surface 2 is dissolved and removed with a solvent (Fig. 4 (c)), then using the extensive portion 6b as a means for forming the shape, an ink-repellent coating is formed on the front surface 2 of nozzle plate 1 (Fig. 4 (d)).

Lastly, the hardened photosensitive resin material 7 on the rear surface 3 of nozzle plate 1 which protects front surface 2 is removed by dissolving with a solvent and ink-repellent coating layer 8 is thus formed on the whole of the front surface 2 of nozzle plate 1 with the exception of the edge of nozzle 4 (Fig. 4 (e)).

In the second embodiment in this application, an ink-repellent coating layer is formed by eutectoid plating on the surface of nozzle plate. However, the formation of the layer by application of a fluorine-containing macro-molecular water-repellent material would be equally satisfactory.

According to the present invention as described above, a water-repellent coating is provided on the nozzle plate surface

surrounding the nozzle in such a way as to leave a portion not exceeding 20% of the diameter of the nozzle uncoated, thereby disruption of the flight of ink droplets due to wetting does not occur because wetting by ink around the nozzle is minimized; and disruption of the flight of ink droplets due to the contact of ink droplets with a water-repellent coating within the inner portion of the nozzle can be reliably suppressed. Further, as a nozzle plate surface treatment the front surface of a nozzle plate was coated with a photosensitive resin which entered at least one part of the inner surface of a nozzle, the resin inside the nozzle inner surface being hardened by exposure directed from the rear surface of the nozzle plate and at the same time a portion of the photosensitive resin directly above the nozzle being hardened to a size at least that of the nozzle diameter, being no larger than 1.4 times that of the nozzle diameter by exposure having reached the front surface of the nozzle, the hardened portion directly above the nozzle acting as a means for forming the shape of a water-repellent plating coating on the front surface of the nozzle plate. Further, a hardened resin plug inside the inner surface of the nozzle totally preventing the lining of the nozzle inner surface by the water-repellent coating, the cause of disruption of the flight of ink droplets. In addition, the energy necessary for the exposure was easy to control. Furthermore, detaching of the hardened photosensitive resin portion above the nozzle on the front surface was avoided, that portion thereby acting as a means for forming the shape of a water-repellent layer on the

nozzle plate surface and enabling the easy and accurate formation of the water-repellent layer.

CLAIMS

1. A nozzle plate comprising at least one nozzle hole for the ejection of ink droplets, and a water-repellent coating formed on a surface of said nozzle plate surrounding the at least one nozzle hole, in such a way as to leave uncoated a portion of said nozzle plate surface surrounding said at least one nozzle hole, said portion not exceeding 20% of the diameter of said at least one nozzle hole.

2. A method of forming a water-repellant coating layer on a nozzle plate surface, the method comprising:

laminating a front surface of said nozzle plate with a photosensitive resin material which may be hardened by exposure to a light source, at least one portion of said photosensitive resin material entering the inner portion of said nozzle;

exposing a portion of said photosensitive resin material directly above said nozzle from a rear surface of said nozzle plate to a light source sufficient to harden a portion of said photosensitive resin material to a size at least that of said nozzle diameter, being no larger than 1.4 times that of the diameter of said nozzle, thereby hardening said photosensitive resin material; and

forming the water-repellent coating layer on the upper surface of said nozzle plate using said hardened portion of said photosensitive resin material as a means to form the shape of said water-repellent coating layer.

3. A method according to claim 2, wherein a photosensitive resin material, which is hardened by exposure to a light source, is provided in the form of a photosensitive resin film, said film being subjected to pressure and one portion of said film entering the inner portion of the nozzle.

4. A method according to claim 2, wherein a photosensitive resin material, which is hardened by exposure to a light source, is used in the form of a photosensitive resin film and a liquid photosensitive resin material, said photosensitive resin film being applied to the front surface of said nozzle plate, whilst said liquid photosensitive resin material is applied to the rear surface of said nozzle plate with one portion entering the inner portion of the nozzle.
5. A nozzle plate surface treatment method comprising:
forming a water-repellant coating layer on the nozzle plate as claimed in any of claims 2 to 4; and
removing the hardened portion of said photosensitive resin material.
6. A nozzle plate comprising at least one nozzle hole for the ejection of ink droplets, and a water-repellent coating formed according to the method of any of claims 2 to 4, on a surface of said nozzle plate surrounding the at least one nozzle hole.
7. A nozzle plate substantially as hereinbefore described, with reference to any one of Figures 1 to 4 of the accompanying drawings.
8. A nozzle plate surface treatment method substantially as hereinbefore described, with reference to any one of Figures 1 to 4 of the accompanying drawings.